

RECEIVED
CENTRAL
FEB 24 2005

Practitioner's Docket No. MI22-1943

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: David L. Dickerson et al.

Application No.: 10/071,456
Filed: 02/08/02

Group No.: 2814
Examiner: A.D. Mai

For: Semiconductor Constructions Having Polysilicon Layer Formed Against Trenches Filled
With Insulative Material (As amended)

Commissioner for Patents
Washington, D.C. 20231


CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being facsimile transmitted to the Patent and
Trademark Office at (703) 872-9306 on the date shown below:

Facsimile Transmittal
Supplemental Information Disclosure Statement
PTO-Form 1449

2/24/05
Date

Robin Saldivia


Signature

Total Pages 3

PLEASE CHARGE DEPOSIT ACCOUNT 23-0925 (Wells St. John P.S.) \$180.00 for
this Supplemental IDS.

(Certification of Facsimile Transmission--page 1 of 1)

RECEIVED
CENTRAL
FEB 24

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/071,456
Filing Date February 8, 2002
Inventor David L. Dickerson et al.
Assignee Micron Technology, Inc.
Group Art Unit 2814
Examiner A.D. Mai
Attorney's Docket No. MI22-1943
Customer No. 021567

Title: Semiconductor Constructions Having Polysilicon Layer Formed Against Trenches
Filled With Insulative Material (As amended)

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

The attached Form PTO-1449 is submitted in compliance with 37 C.F.R. §§ 1.56.
Pursuant to Federal Register Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies
of any cited U.S. patents or U.S. published applications are included herewith. Copies of
all other cited art references, if any, are attached. No admission is made regarding
whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Date: 2-24-05



D. Brent Kenady
Reg. No. 40,045

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1943		SERIAL NO. 10071.456	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT David L. Dickerson et al.			
				FILING DATE February 8, 2002		GROUP 2814	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,406,977 B2	06/02	Dickerson et al.			
	AB	6,420,268 B2	07/02	Moore et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation Yes No
	AM						
	AN						
	AO						
	AP						
	AQ						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR						
	AS						
	AT						
EXAMINER				DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							